



AF 1763

500.41253X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE EXPEDITED PROCEDURE PURSUANT TO 37 CFR §1.116 REQUESTED Attn: Mail Stop AF

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Applicants:

A. KAGOSHIMA, et al.

Serial No.:

10/080,539

Filed:

February 25, 2002

For:

APPARATUS AND METHOD FOR PRODUCING

SEMICONDUCTORS

Group:

1763

Examiner:

K. Moore

AMENDMENT AFTER FINAL

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 **February 3, 2004**

Sir:

In response to the final Office Action (Paper No. 7) dated on November 3,

2003, please amend the above-identified application as follows.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.